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Complete if Known

Application Number	10/613,513
Filing Date	July 3, 2003
First Named Inventor	LIM, Brian Y.
Art Unit	1725
Examiner Name	ELVE, Maria Alexandra
Attorney Docket Number	ATO-001.00

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U. S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

**Examiner
Signature**

M. Alexandra Elve

Date Considered

8/5/05

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)			Application Number	10/613,513	
			Filing Date	July 3, 2003	
			First Named Inventor	LIM, Brian Y.	
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Sheet	2	of *	2	Attorney Docket Number	ATO-001.00

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NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
AE		L.C. QIN, D. ZHOU, A.R. KRAUSS, D. M. GRUEN; "Growing Carbon Nanotubes By Microwave Plasma-Enhanced Chemical Vapor Deposition"; Appl. Phys. Lett.; June 29, 1998; pp. 3437-3439; Vol. 72, No. 26	
AE		DANIEL L. JEAN, CHAD E. DUTY, BRIAN T. FUHRMAN, W. JACK LACKEY; "Precision Carbon Deposition Using Pyrolytic Laser Chemical Vapor Deposition (LCVD)"; 11th Annual Solid Freeform Fabrication Symp.; Aug. 7-9, 2000; pp. 73-79 (but copy supplied is from: http://www.me.gatech.edu/Lackey/djsff2000.pdf , via: http://www.me.gatech.edu/Lackey/Biosketch/biosketch.html)	
AE		NATHAN R. FRANKLIN, YIMING LI, ROBERT J. CHEN, ALI JAVEY, and HONGJIE DAI; "Patterned Growth of Single Walled Carbon Nanotubes on Full 4-Inch Wafers"; Appl. Phys. Lett.; Dec. 31, 2001; pp. 4571-4573; Vol. 79, No. 27	
AE		F. ROHMUND and R.-E. MORJAN, G. LEDOUX and F. HUISKEN, R. ALEXANDRESCU; "Carbon Nanotube Films Grown by Laser-Assisted Chemical Vapor Deposition"; J. Vac. Sci. Technol.; May/June 2002; pp. 802-811; B 20 (3)	
AE		R. ALEXANDRESCU, A. CRUNTEANU, R.-E. MORJAN, I. MORJAN, F. ROHMUND, L.K. L. FALK, G. LEDOUX, F. HUISKEN; "Synthesis of Carbon Nanotubes by CO ₂ -Laser-Assisted Chemical Vapor Deposition"; Infrared Phys. Technol.; 2003; pp. 43-50; 44	

Examiner Signature	M. Alexandra Elve	Date Considered	8/5/05
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